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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Chishio KOSHIMIZU et al.) Group Art Unit: 1763
Application No.: 10/675,966) Examiner: KACKAR, RAM N
Filed: October 2, 2003))
For: PLASMA PROCESSING APPARATUS AND PLASMA PROCESSING METHOD) Confirmation No. 6290)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed February 8, 2007, the period for response having been extended through August 8, 2007 by a petition for extension of time of three months and fee payment filed concurrently herewith, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.